



## Development of diagnostics Based on Scintillating Screens for Ion Beam Characterization



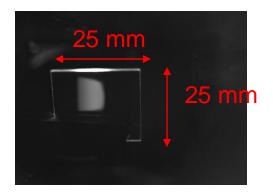
#### Marion RIPERT, Frankfurt University



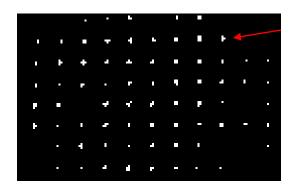
09-11/11/2011 DITANET International Conference – Accelerator Diagnostic Techniques

### **Objectives : "ideal" scintillator**

Beam profiler



Pepper-pot device



Ø pepper-pot holes 50 um Drift distance: 60 mm

### Limiting factor for measuring small beams:

## Spatial resolution of the material

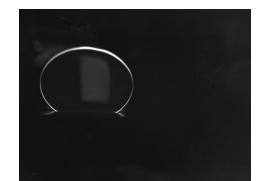
In general, Limits from individual grain size; (um scale) Crystals - uniform at molecular level  $\rightarrow$  high resolution !

## Resolution of CCD camera

High resolution CCD camera with a varifocal lens to adjust the field of view

### **Experiment 1: Beam Profile Monitor** Investigation of the time dependence of Light output at MPI – K (Heidelberg) for low energy high intensity beam

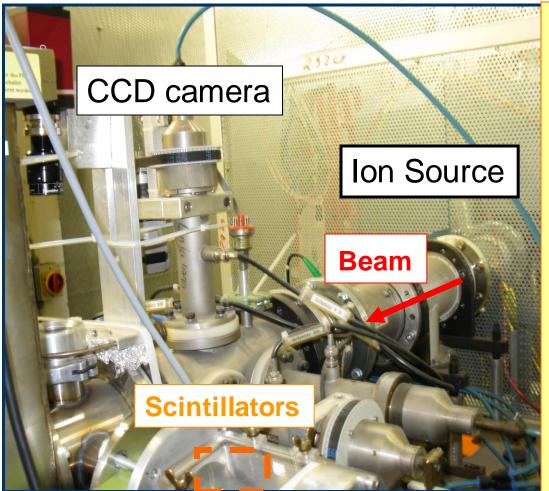
### List of materials



A total irradiation time of 1.5 sec to 2 sec have been applied to each material

Туре	Material	
Inorganic Doped	YAG:Ce, YAP:Ce	
Inorganic	Sapphire,	YAG
Undoped		
Quartz	Herasil 3	
	Infrasil 30	
	Suprasil 2	
Glass	D 263 T	

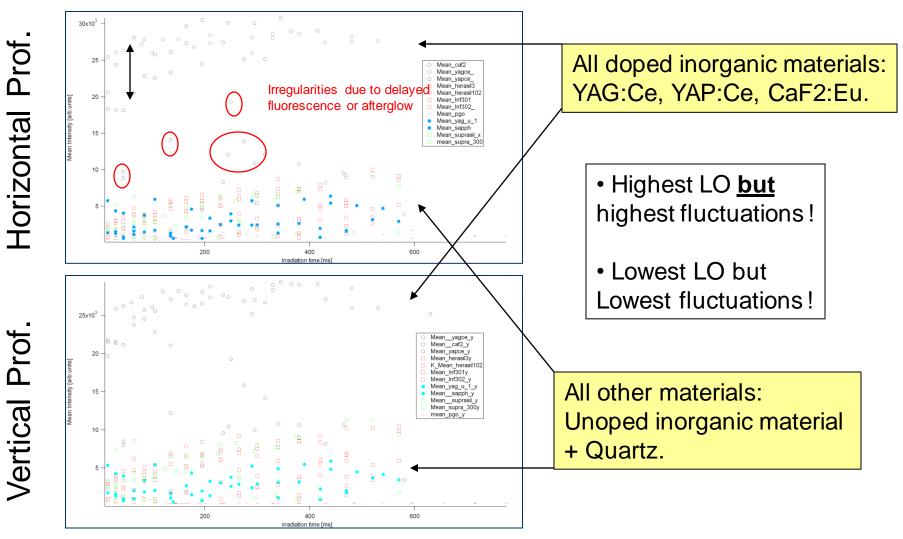
### Experiment 1: Ion beam irradiation Test Setup at MPI-K



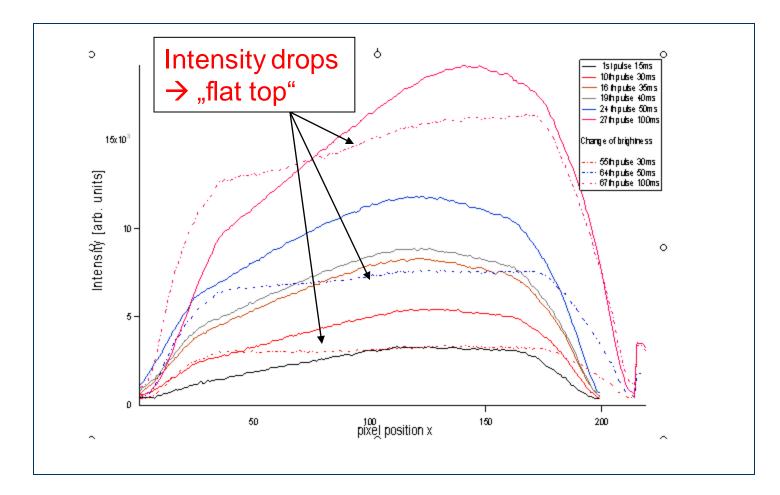
Ion Beam (proton) Characteristics :

✓ Energy 8 KeV/u
✓ Beam Current 10 µA
✓ Particles per pulse :
9.4\*10^11- 3\*10^13
✓ Variable Pulse
Length 15 ms - 500 ms
✓ Frequency : 1 Hz
✓ 3 Macro Pulses of
each beam pulse

### **Main results for all scintillators:** Mean Light Output for all materials [a.u] v.s Irradiation Time [ms]



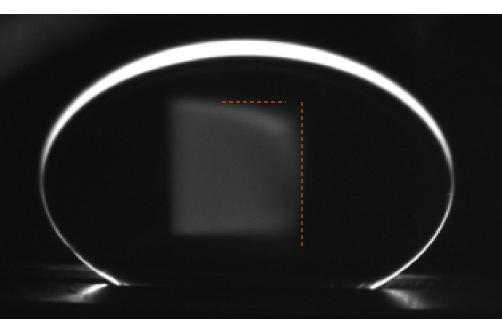
#### **Reproducibility:** "broken tooth" shape Example of Herasil 3 - Intensity [a.u] v.s Position [pixels] for 65 beam pulses (total integrated time: 2000ms)

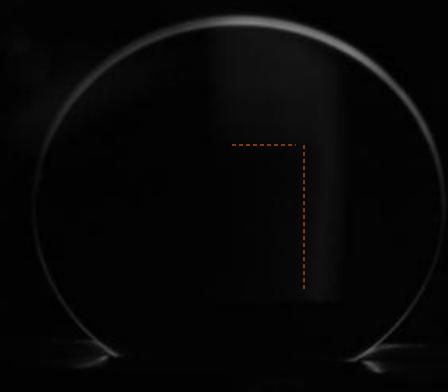


# Degradation Effects : YAG Undoped within a irradiation time of 1.3 sec

#### 2nd Macro pulse of 50 ms pulse

## One day later, 1st Macro pulse of 50 ms pulse

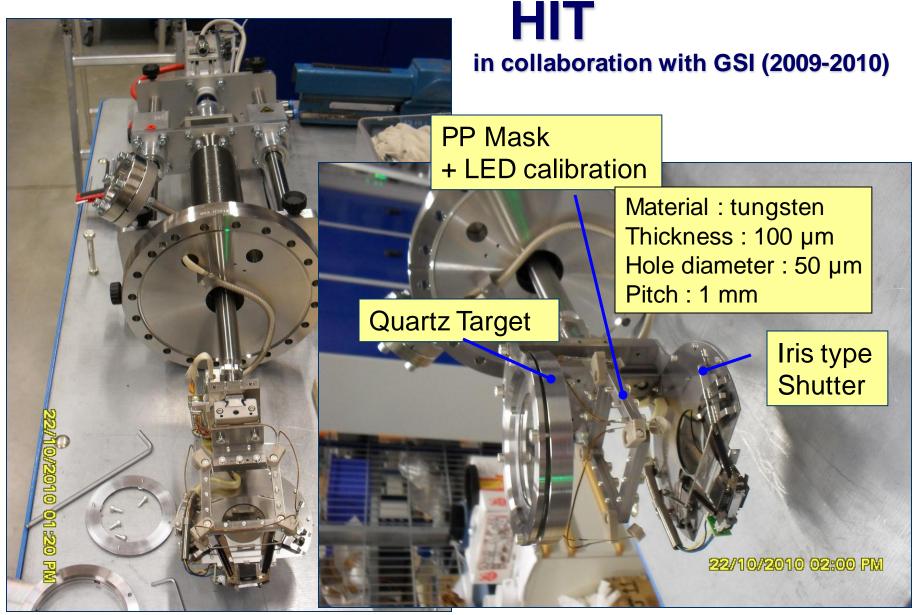




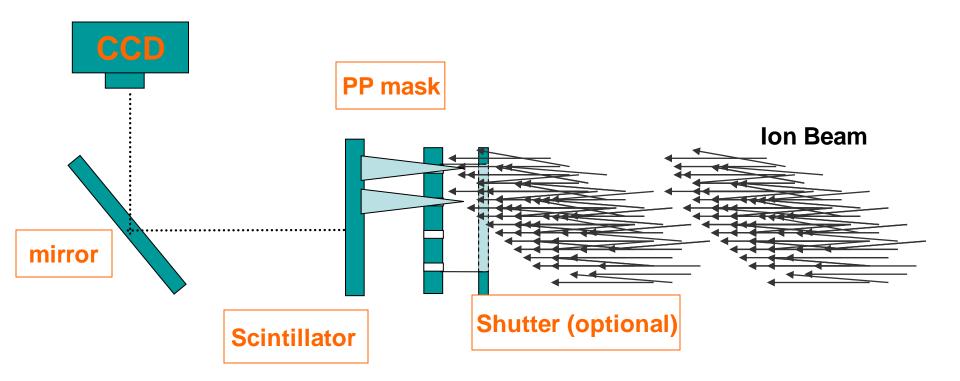
### **Results & Conclusion**

- A complete statistical analysis  $\rightarrow$  No "Ideal" Scintillator could be found !
- **Good candidate**: Quartz (Herasil 3 and Infrasil 3) and even better for lower current !
- **Potential candidate:** YAG:Ce, CaF2:Eu, Suprasil1, Infrasil 30.
- Need further investigation to explain satisfactorily large fluctuations of LO and non-repeatability of measurements.
- As a target viewer: add borosilicate glass (low LO but cheap!)
- As **part of the Pepper-pot**: Quartz are the most reliable one but only for a limited time (for low energy high intensity)!

## Experiment 2: Pepper-pot device at

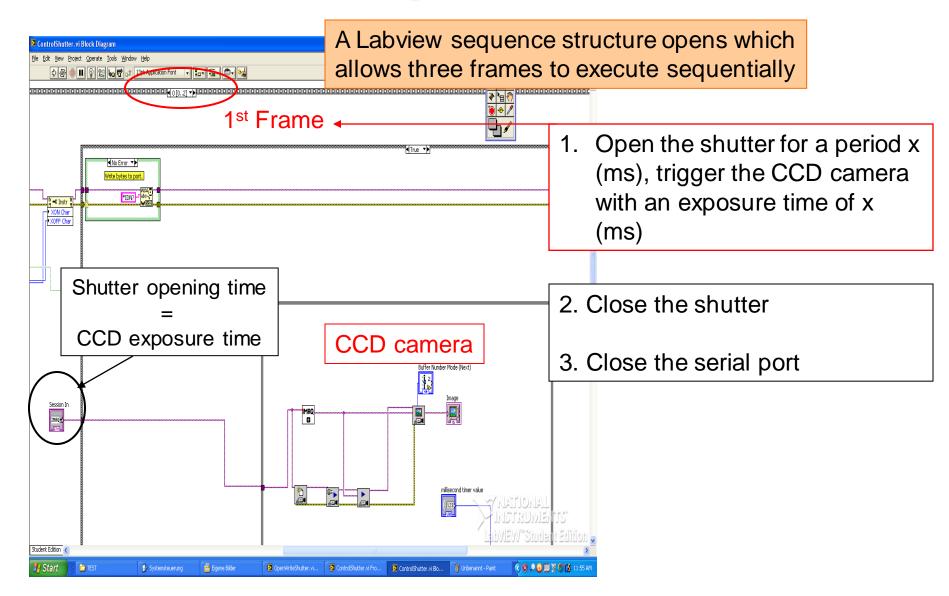


### Pepper Pot Device – A Fast Imaging device



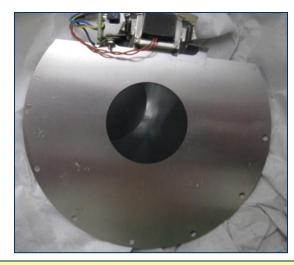
Allow to create an image that portrays the distribution of particles in the beam ( "emittance" ) in (x,x',y,y').

### Main part of the Data Acquisition System



### **Experiment 2: Pepper-pot device with**

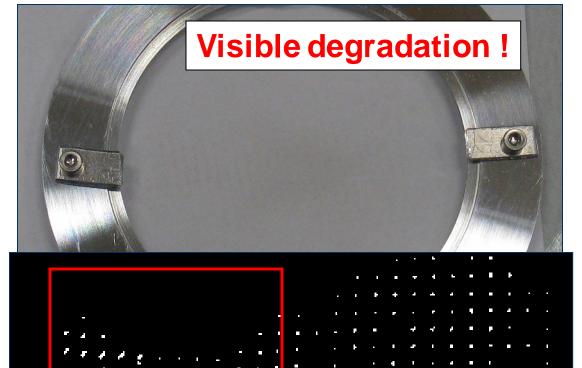
**Quartz** Secondment of Dr. Susanta DAS (E.R at Stockolm Univ.)



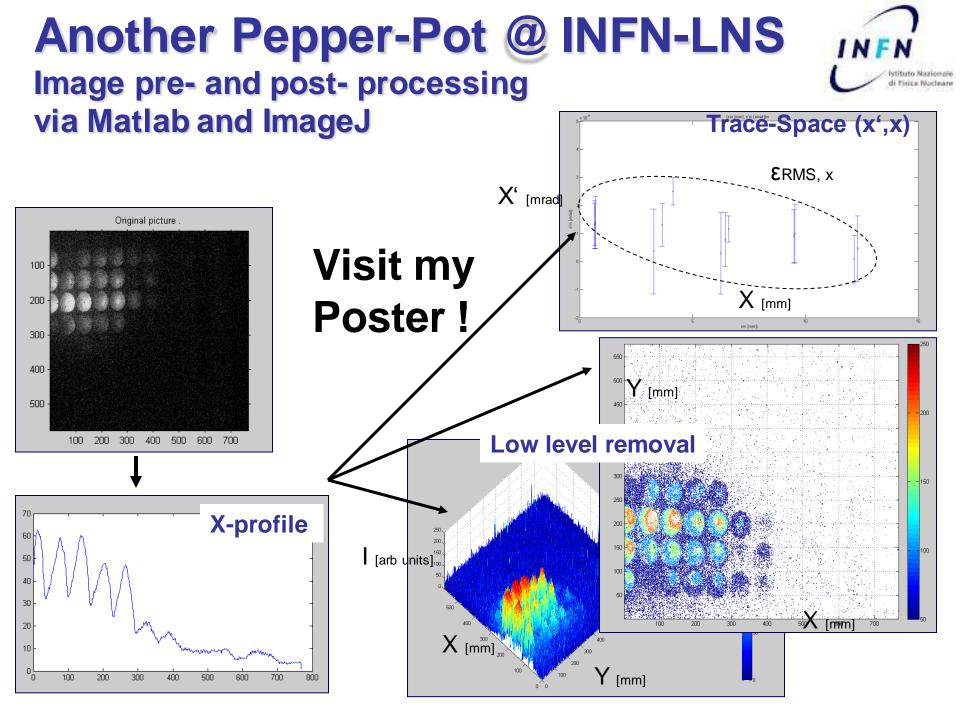
<u>Algorithm:</u> <u>"spots/holes" matrix</u> <u>combination</u>

1 hole  $\equiv$  1 beamlet ? No !

→ Does this pepper-pot data can reflect the real emittance ?



% Beam



### Conclusion

- **Experiment 1**: Further experiment to better understand the occurrence of fluctuations and radiation damage
- → spectroscopy (combination of color center with high flux rate)
- **Experiment 2:** Pepper pot mechanical device and DAQ completed.
- Visit my poster on emittance method and algorithm !

### **Acknowledgements**

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## APPENDIX

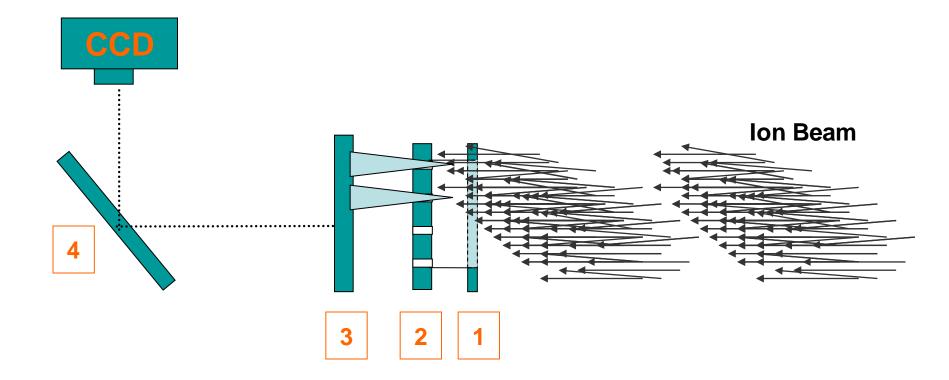
### Ion Beam-Material Irradiation Test @ Max Planck Institute (Heidelberg)

Investigate 3 scintillators materials in one machine run



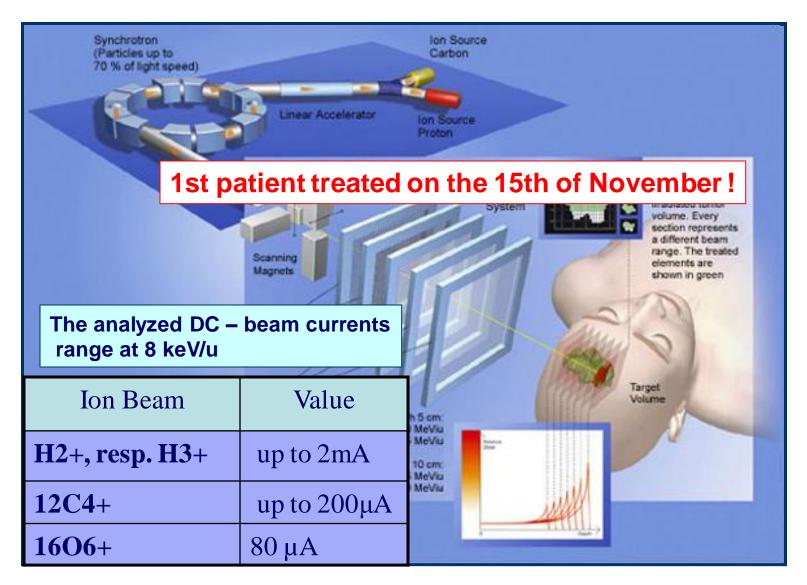
<u>Screen dimensions</u> : 20 x 17/18 mm or diam 17/18 mm Thickness of 0.1 mm to 1mm

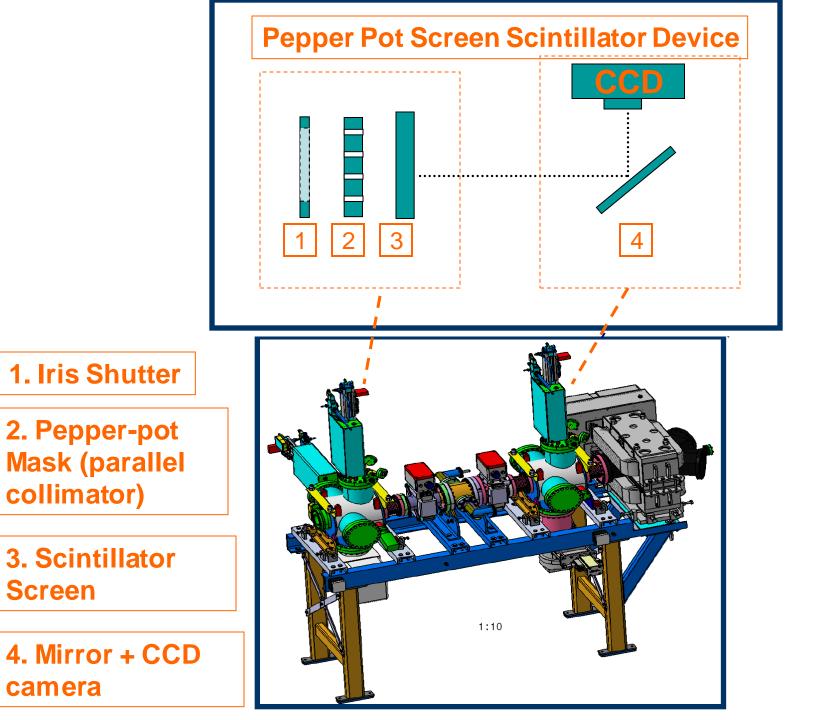
### Pepper Pot Device – A Fast Imaging device



Allow to create an image that portrays the distribution of particles in the beam

### **HIT facility**





### Why using a Pepper Pot Device ?

Replaced traditional wire /slit scanners ( destruction due to thermal strain )

• Want to measure both x-y components of the beam emittance simultaneously in one shot and data obtained in real time

 $\rightarrow$  uses a slit to select a portion of the beam for analysis

Advantages / Disadvantages

**Two-slit scanner :** 

Multiwire collector :

Allison-type scanner :

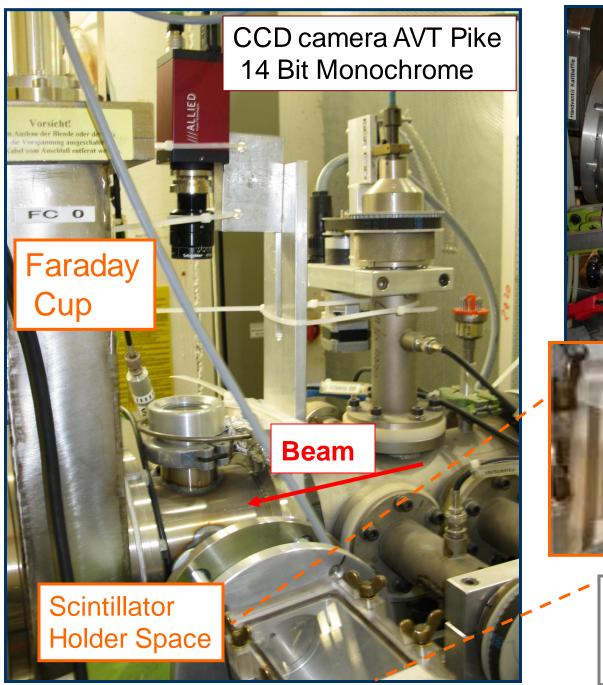
**Pepper-Pot:** 

slow

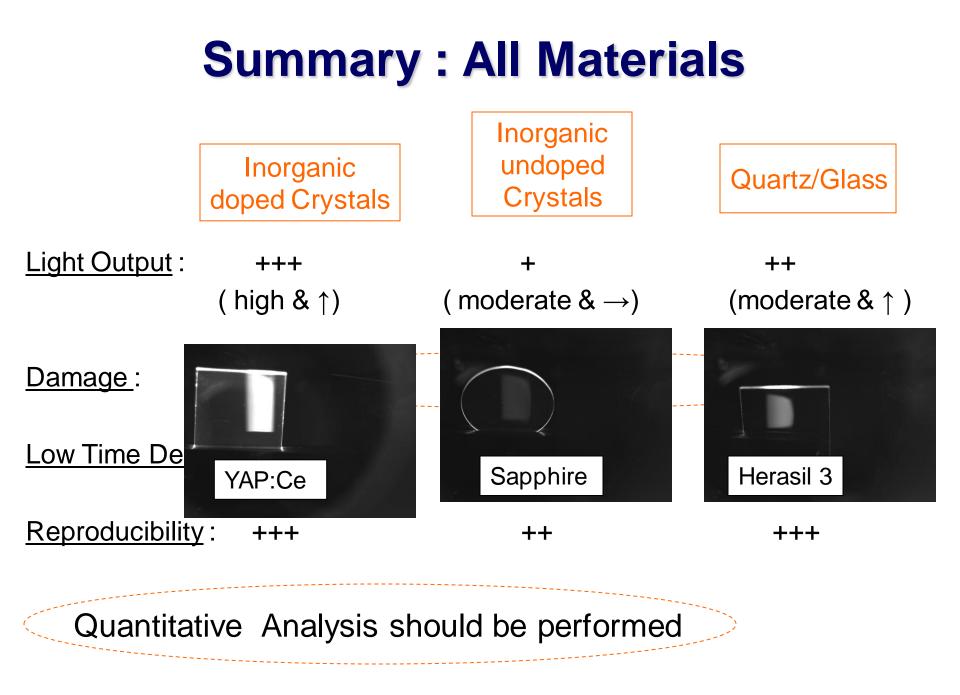
Faster than two slits method but need amplifier for each wire

slower than pepper pot

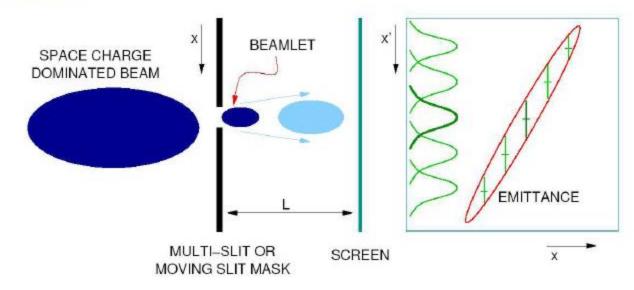
fast, need "adequate" scintillator

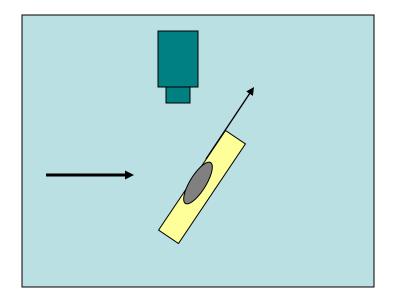


Can to Scintillator Set on the holder @ 45 degrees angle



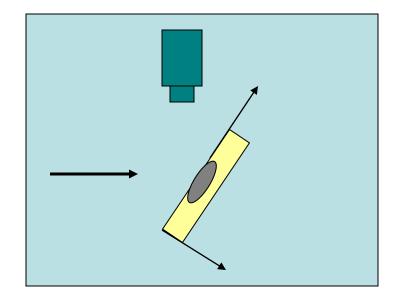
- thin, emittance dominated beamlets
- After drift the width of expanded beamlet is measured with screen
- Beam trace space (average momentum and momentum spread) is reconstructed from position and width of beamlet images on screen -> Emittance is then fitted in phase space
- Need slit masks with actuators and screen station to measure emittance





### **Profile Monitor**

Use a scintillator to produce an image of the transverse beam distribution



- Crystal Why?
- uniform individual grain scale **not a limiting factor** : inorganic (electronic band structure found in crystals), doped and undoped (light output vs stronger structure) inorganic, quartz crystal and borosilicate glass (advantages LO, grain size, cost, etc..)
- **CCD** camera FOV combined to focal lens have to be configured to obtain a adequate pixel resolution. The camera pixel size is 7.4 um sets the resolution limit.